

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : Unassigned Confirmation No. Unassigned
Applicant : Jurriaan Schmitz *et al.*
Filed : Concurrently
TC/A.U. : Unassigned
Examiner : Unassigned

Docket No. : **BE02 0028US**
Customer No. : 24738

Title : Method of Manufacturing a Semiconductor Device with a Silicon
Body Provided with Field Isolation Regions Consisting of Grooves
Filled with Isolating Material

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to calculation of the filing fee and examination please amend the above-identified application as follows:

Amendments to the Specification there are no amendments in this paper.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.